



**ELECTRONIC COPY**

LG766646556  
Report verification at igi.org



January 24, 2026  
IGI Report Number **LG766646556**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **CUT CORNERED  
RECTANGULAR MIXED CUT**  
Measurements **9.63 X 6.90 X 4.86 MM**  
**GRADING RESULTS**  
Carat Weight **3.09 CARATS**  
Color Grade **FANCY INTENSE YELLOW**  
Clarity Grade **VVS 2**

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**GRADING RESULTS**

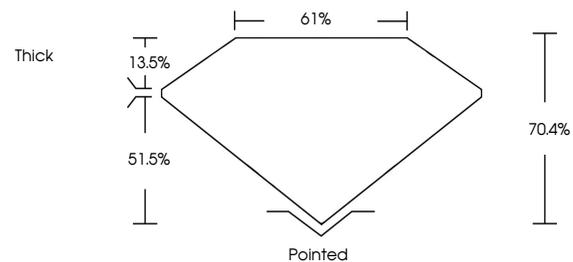
Carat Weight **3.09 CARATS**  
Color Grade **FANCY INTENSE YELLOW**  
Clarity Grade **VVS 2**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG766646556**

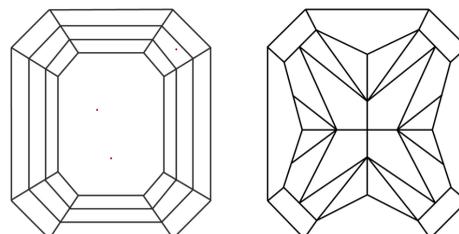
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

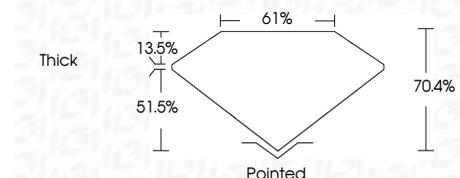
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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CUT CORNERED RECT. MIXED CUT  
3.09 CARATS  
FANCY INTENSE YELLOW  
VVS 2  
9.63 X 6.90 X 4.86 MM  
70.4%  
61%  
Thick  
Pointed  
EXCELLENT  
EXCELLENT  
NONE  
IGI LG766646556  
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